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(12) **United States Design Patent** (10) **Patent No.:** **US D933,725 S**  
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(54) **DEPOSITION RING FOR A SUBSTRATE PROCESSING CHAMBER**

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(51) **LOC (13) Cl.** ..... **15-09**

(52) **U.S. Cl.**  
USPC ..... **D15/138; D13/182**

(58) **Field of Classification Search**  
USPC ..... D23/249, 259, 262, 269; D15/138, 139, D15/143, 144, 144.1, 144.2, 150, 199;  
(Continued)

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(57) **CLAIM**

The ornamental design for a deposition ring for a substrate processing chamber, as shown and described.

**DESCRIPTION**

FIG. 1 is an enlarged top isometric view of a deposition ring for a substrate processing chamber, according to the first embodiment of the novel design.

FIG. 2 is a top plan view thereof.

FIG. 3 is a bottom plan view thereof.

FIG. 4 is a front elevation view thereof.

FIG. 5 is a back elevation view thereof.

FIG. 6 is a left side elevation view thereof.

FIG. 7 is a right side elevation view thereof.

FIG. 8 is a cross-sectional view taken along line 8-8 in FIG. 2, enlarged for clarity.

FIG. 9 is an enlarged top isometric view of a deposition ring for a substrate processing chamber, according to the second embodiment of the novel design.

FIG. 10 is a top plan view thereof.

FIG. 11 is a bottom plan view thereof.

FIG. 12 is a front elevation view thereof.

FIG. 13 is a back elevation view thereof.

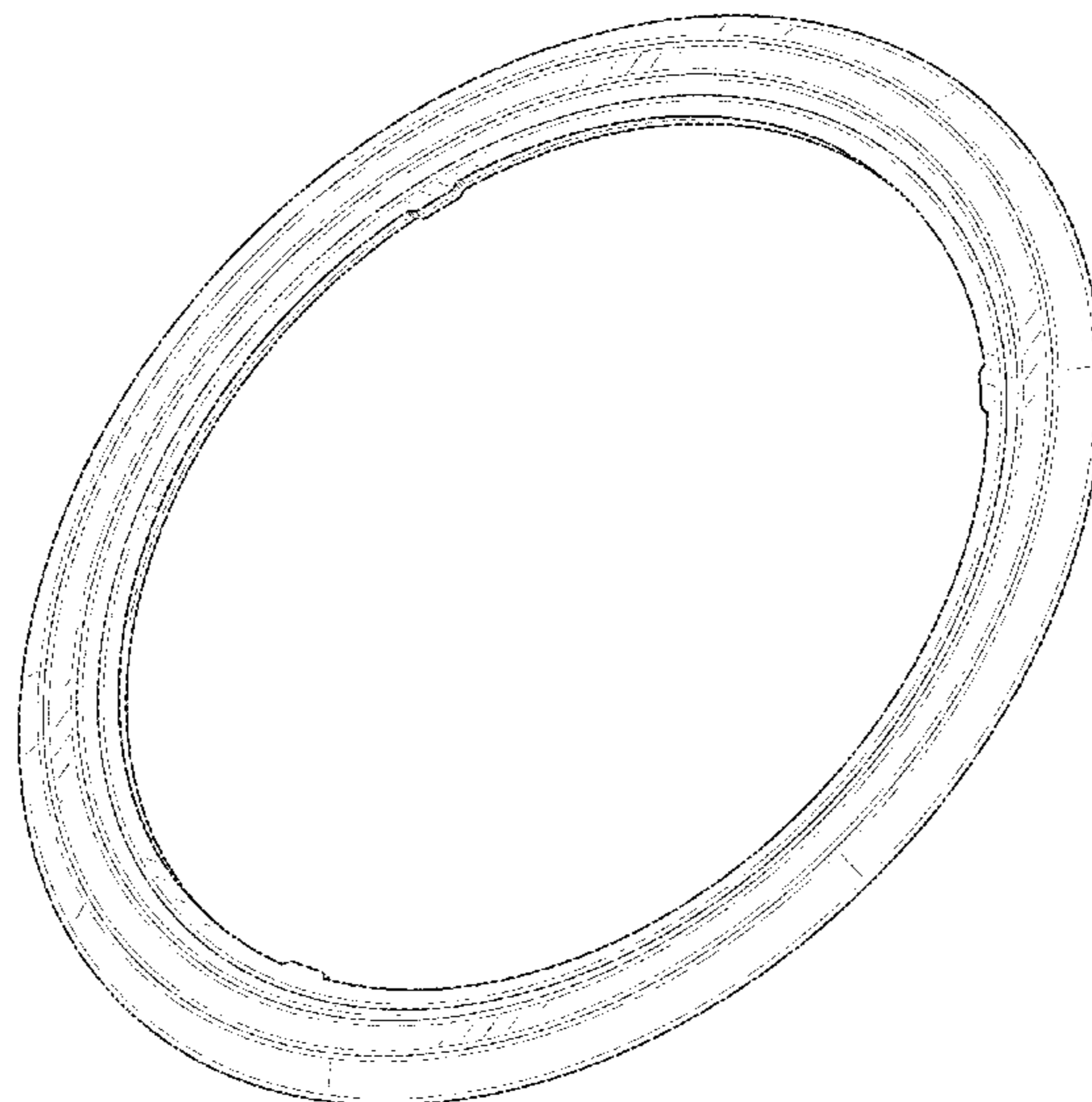
FIG. 14 is a left side elevation view thereof.

FIG. 15 is a right side elevation view thereof; and,

FIG. 16 is a cross-sectional view taken along line 16-16 in FIG. 10, enlarged for clarity.

The dashed lines in FIGS. 1-8 represent unclaimed environment forming no part of the claimed design.

**1 Claim, 16 Drawing Sheets**



(58) **Field of Classification Search**

USPC ..... D13/118, 122, 133, 162, 182, 184, 199;  
 D22/113, 119  
 CPC ..... H01J 37/3414; H01J 37/3423; H01L  
 21/02631; H01L 2221/68363; H01L  
 2224/75186-75189; H01L 21/67742;  
 H01L 21/0226; H01L 21/02263; H01L  
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See application file for complete search history.

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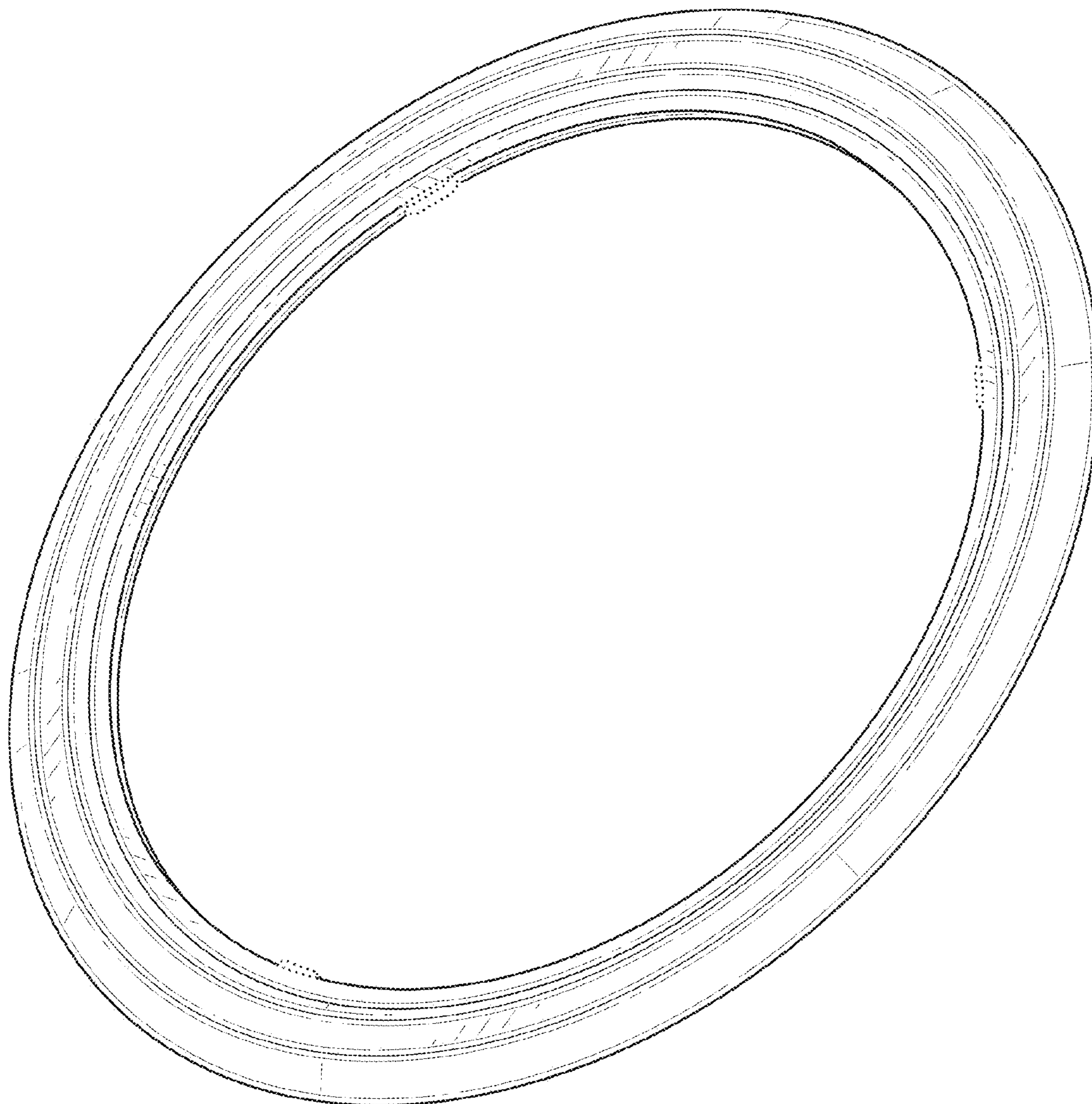
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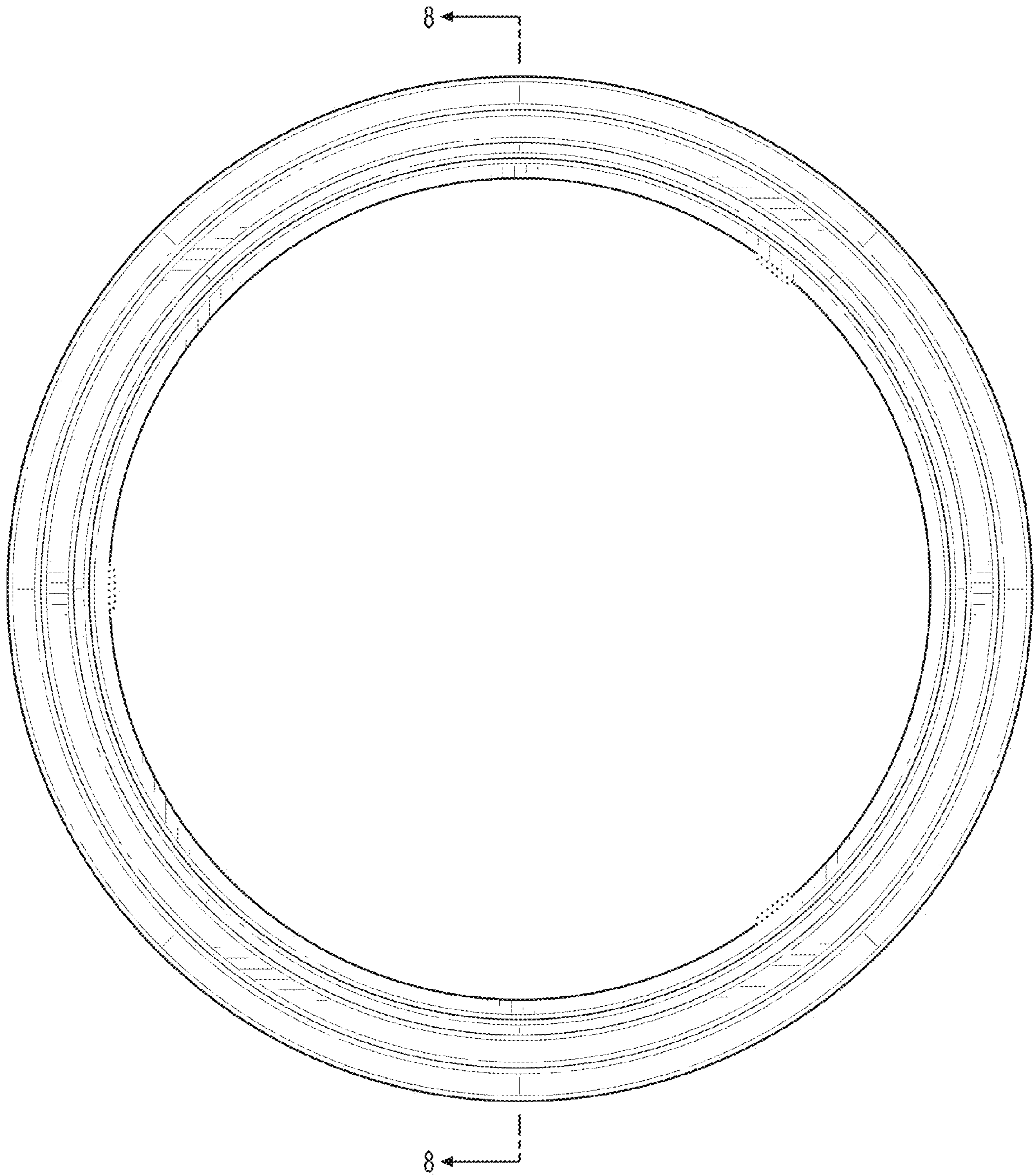
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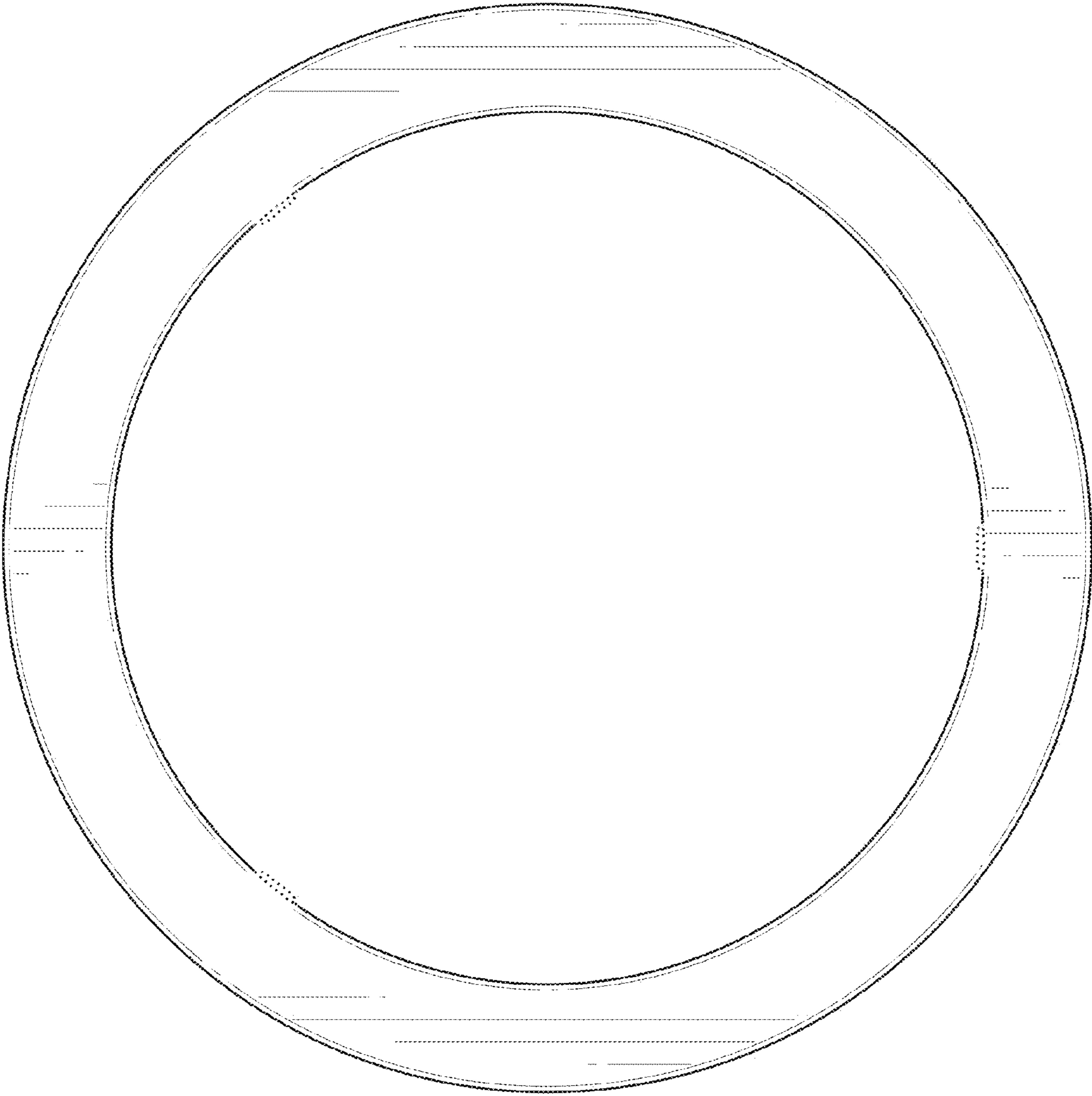
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**FIG. 1**



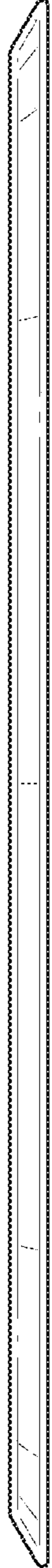
**FIG. 2**



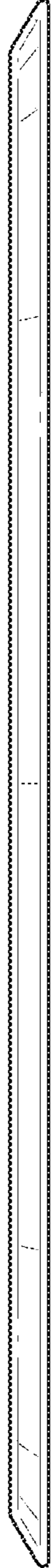
**FIG. 3**



**FIG. 4**

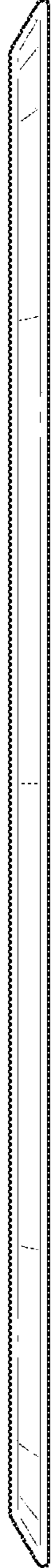


**FIG. 5**

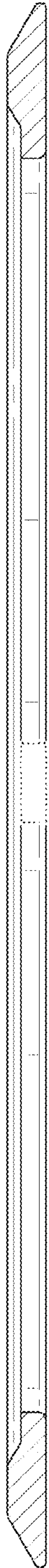


**FIG. 6**

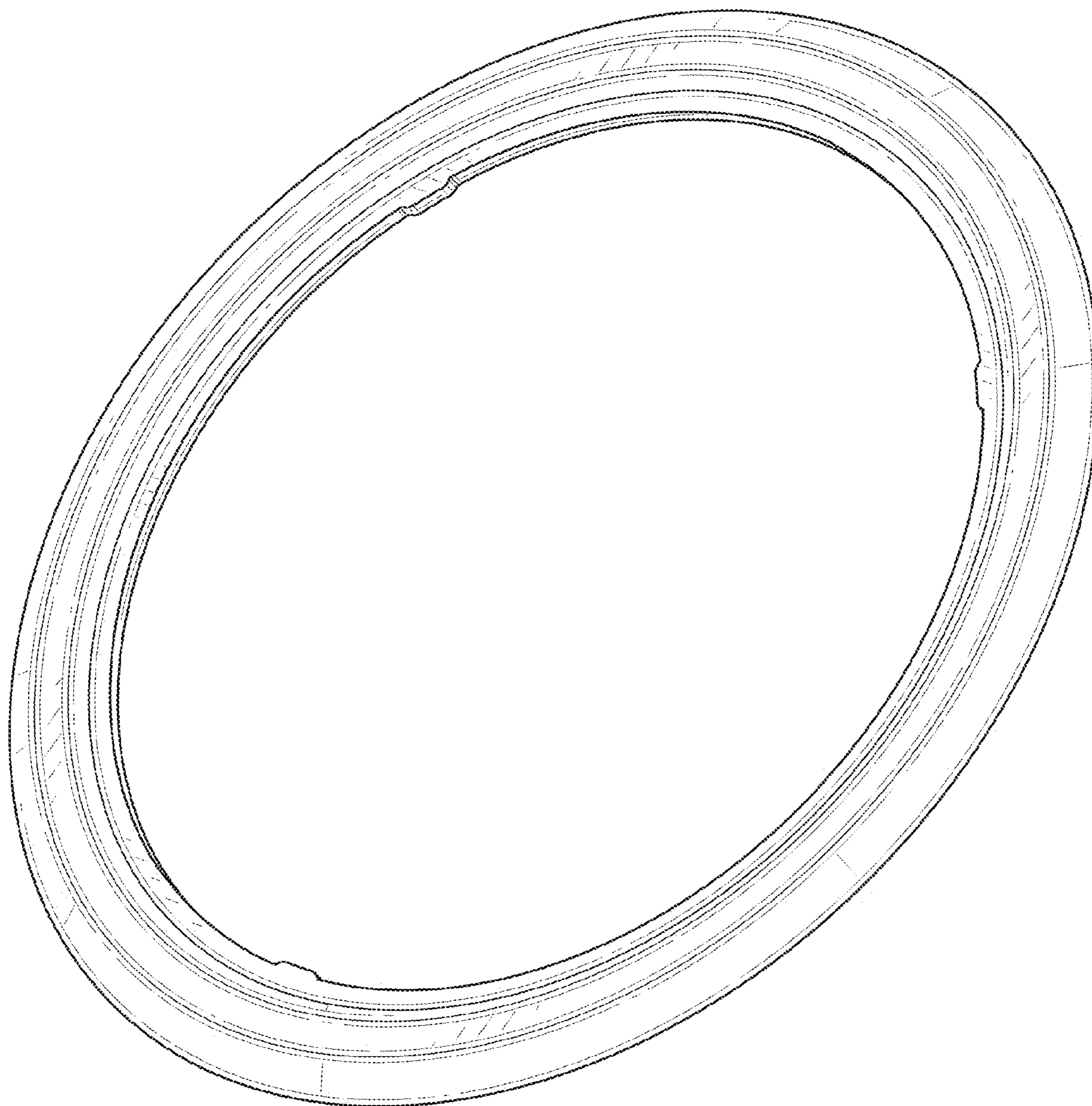




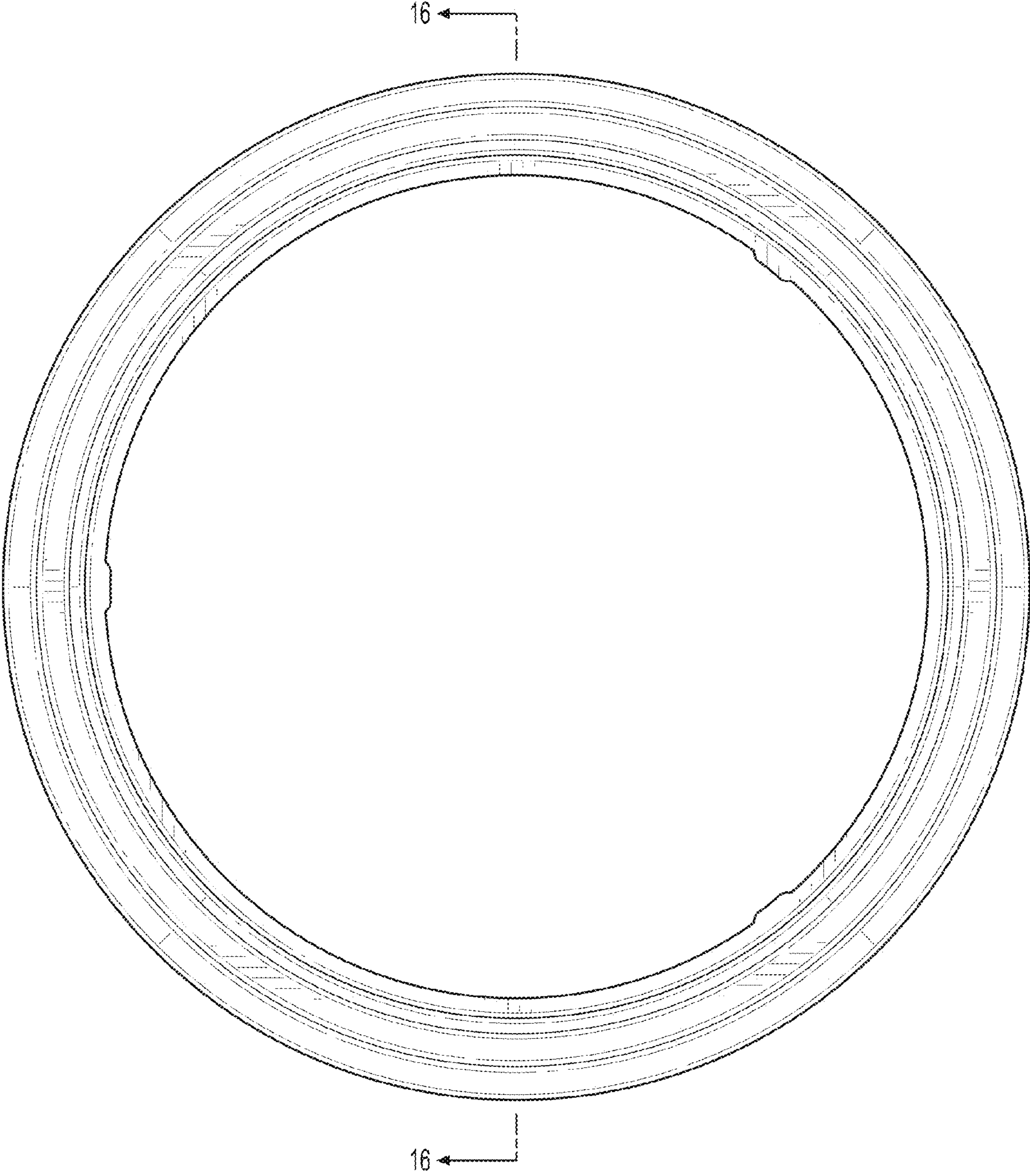
**FIG. 7**



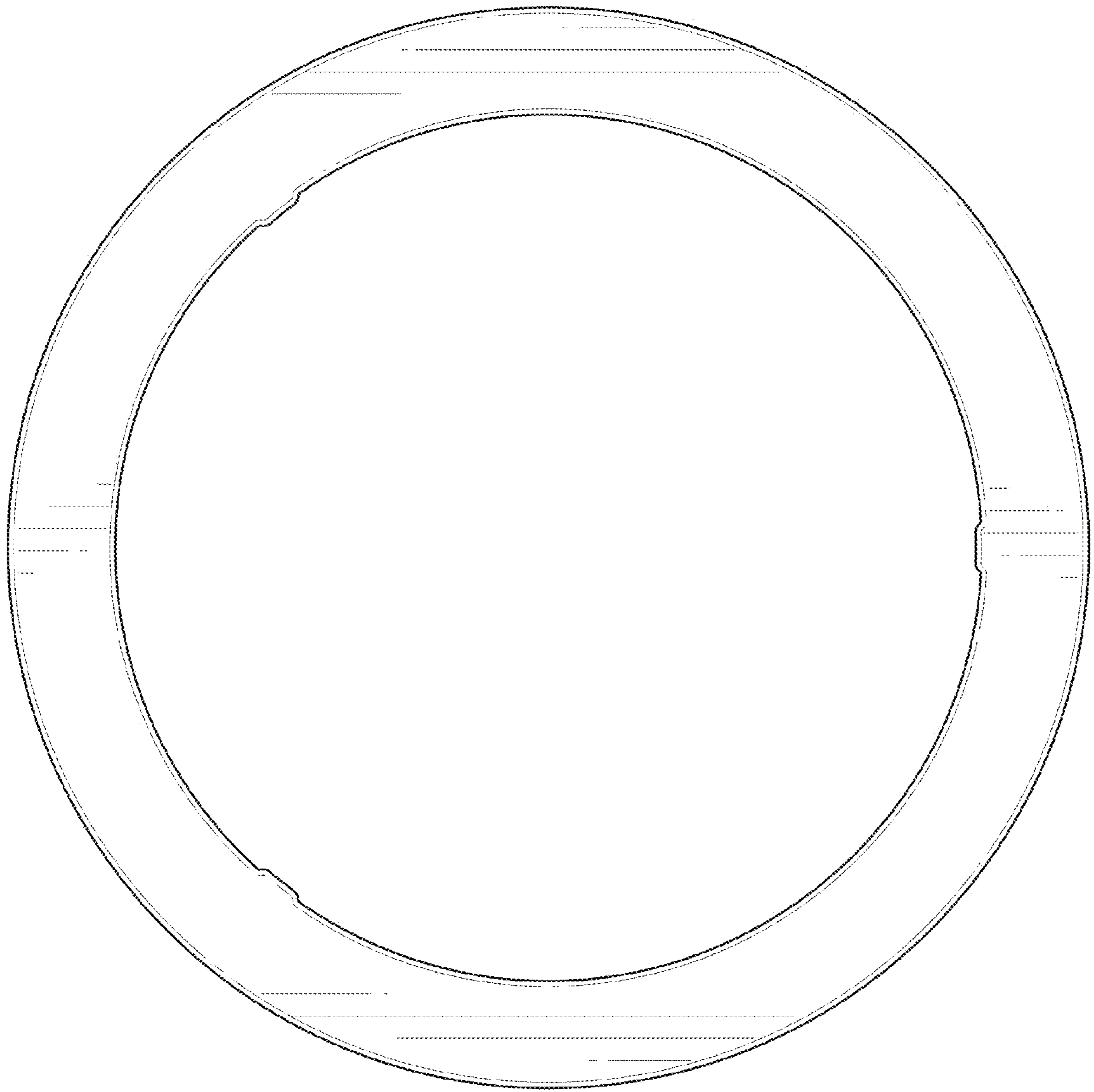
**FIG. 8**



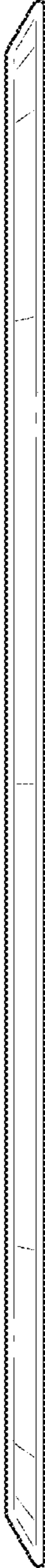
**FIG. 9**



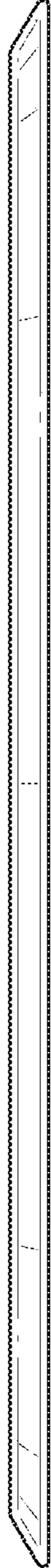
**FIG. 10**



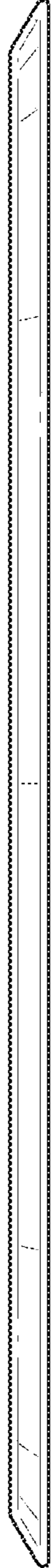
**FIG. 11**



**FIG. 12**

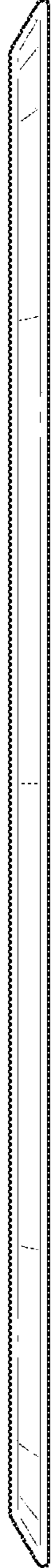


**FIG. 13**

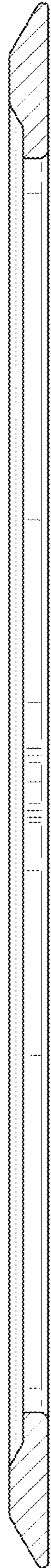


**FIG. 14**





**FIG. 15**



**FIG. 16**